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PATENT
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a Fred
07/24/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Xu et al.

Serial No. 09/854,177

Filed: May 10, 2001

For: METHOD AND SYSTEM FOR
DETECTING METAL
CONTAMINATION ON A
SEMICONDUCTOR-WAFER

Group Art Unit: 2822
Examiner: Jeff Vockrodt

Atty. Dkt. No. 5589-00501

I hereby certify that this correspondence is being deposited
with the U.S. Postal Service as First Class Mail in an envelope
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Box 1450; Alexandria, VA 22313, on the date indicated below:

May 15 2003
Date

Pamela Gerik
Pamela Gerik

AMENDMENT; RESPONSE TO OFFICE ACTION MAILED MAY 6, 2003

MS: Non-Fee Amendment
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313

Dear Sir/Madam:

Responsive to the Office Action of May 6, 2003, please amend the case as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 10 of this paper.

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